

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)

NEC 532

Application Number

10/623,952

Applicant(s)

KURIHARA et al.

Filing Date

July 21, 2003

Group Art Unit

2831

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
LB		06-069366	11.03.1994	JAPAN (w/Abstract)	H01L	23/08		✓
LB		2000-183204	30.06.2000	JAPAN (w/Abstract)	H01L	23/02		✓
LB		2001-196488	19.07.2001	JAPAN (w/Abstract)	H01L	23/08		✓
		2001-044228	16.02.2001	JAPAN (w/Abstract)	H01L	21/56		✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

Dhiru Patel

DATE CONSIDERED

11/3/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
LBO		2002/0089097	7.11.02	SILBERBROOK	264	496	
LBO		3,988,196	10.26.76	WANESKY	156	541	
LBO		5,889,323	3.30.99	TACHIBANA	257	704	

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
LBO		2000-183204	6.30.00	JAPAN (w/abstract)	H01L	23/02	*✓	
				* Translation for				
				abstract only				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

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